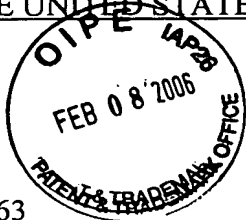


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of:)
 Zhang)
 Application No: 10/743,963)
 Filed: December 22, 2003)
 For: CHEMICAL MECHANICAL PLANARIZATION)
 (CMP) SYSTEM AND METHOD FOR PREPARING)
 A WAFER IN A CLEANING MODULE)

Attorney Docket No: LAM2P456
 Examiner: RACHUBA, M.
 Group Art Unit: 3723
 Date: February 3, 2006

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on February 3, 2006.

Signed:

Michael L. Gencarella

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE RATE FEE	ENTITY
TOTAL CLAIMS	9 -	22	00	X25 = \$	OR	X50 = \$	
INDEP CLAIMS	1 -	04	00	X100 = \$	OR	X200 = \$	
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		X360	\$
			TOTAL	\$		\$	

- ☐ Applicant(s) hereby petition for a month(s) extension of time to respond to the outstanding Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P456).
- ☐ Enclosed is our Check No. in the amount of to cover the additional claim fee and/or extension of time fees.
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P456). A copy of this sheet is enclosed.

Respectfully submitted,
 MARTINE PENILLA & GENCARELLA, LLP

Michael L. Gencarella, Esq.
 Registration No. 44,703

710 Lakeway Drive, Suite 200
 Sunnyvale, CA 94085
 Telephone: (408) 749-6900
 Customer Number 25920



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)	
Xiuhua Zhang)	Examiner: Rachuba, Maurina
Application No. 10/743,963)	Art Unit: 3723
Filed: December 22, 2003)	Docket No. LAM2P456
For: CHEMICAL MECHANICAL PLANARIZATION)	Date: February 03, 2006
(CMP) SYSTEM AND METHOD FOR PREPARING)	
<u>A WAFER IN A CLEANING MODULE</u>)	

CERTIFICATE OF EXPRESS MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service on **February 03, 2006**, in an envelope as first class mail, addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: _____

Michael L. Gencarella

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office action dated November 3, 2005, please enter the following amendments and remarks.

Amendments to the claims are reflected in the listing of claims, which begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.